



Image

PATENT

~~RCE~~
11765

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re application of:

Wen-Ben CHOU et al.

Application No: 09/998,858

Filed: October 31, 2001

For: METHOD AND APPARATUS FOR NITRIDE
PACER ETCH PROCESS IMPLEMENTING
-IN SITU INTERFEROMETRY ENDPOINT
DETECTION AND NON-INTERFEROMETRY
ENDPOINT MONITORING

) Docket No: LAM2P295

) Examiner: Chen, K.

) Group Art Unit: 1765

) Date: February 9, 2004

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on February 9, 2004.

Signed: 
Courtney F. Yadegar

REQUEST FOR CONTINUED EXAMINATION (RCE) TRANSMITTAL

Mail Stop: **RCE**
Commissioner for Patents
Alexandria, VA 22313-1450

Sir:

1. Submission required under 37 C.F.R. § 1.114

- a. ☐ Previously submitted
- i. ☐ Consider the amendment(s)/reply under 37 C.F.R. § 1.116 previously filed on _____.
- ii. ☐ Consider the arguments in the Appeal Brief or Reply Brief previously filed on _____.
- iii. ☐ Other _____.
- b. ☒ Enclosed
- i. ☒ Amendment/Reply
- ii. ☐ Affidavit(s)/Declaration(s)
- iii. ☐ Information Disclosure Statement (IDS)
- iv. ☐ Other _____

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02 FC:1251

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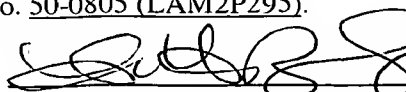
2. Miscellaneous

- a. ☐ Suspension of action on the above-identified application is requested under 37 C.F.R. § 1.103(c) for a period of _____ months.
- b. ☐ Other _____

3. Fees

- a. ☒ Check in the amount of \$880.00 is enclosed for:
- i. ☒ RCE fee required under 37 C.F.R. § 1.17(e);
- ii. ☒ Extension of time fee (37 C.F.R. §§ 1.136 and 1.17); and
- iii. ☐ Other _____.
- b. ☒ The Director is hereby authorized to charge any fees, or credit any overpayments, to Deposit Account No. 50-0805 (LAM2P295).

Date: February 9, 2004


Fariba Yadegar-Bandari, Esq.
Registration No. 53,805